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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Confirmation No. 6339**
Kazufumi SATO et al. : Attorney Docket No. 2003_1687
Serial No. 10/716,632 : Group Art Unit 1752
Filed November 20, 2003 : Examiner John S. Y. Chu
POSITIVE-WORKING PHOTORESIST : **Mail Stop: Amendment**
COMBINATION

RESPONSE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated October 19, 2005, please amend the present application as follows: